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PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventors: Minna Hovinen et al.

Application No.: 10/689,332

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For: METHOD FOR DETERMINING ION
CONCENTRATION AND ENERGY OF
SHALLOW JUNCTION IMPLANTS

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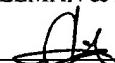
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CERTIFICATE OF MAILING

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